## Claims:

- 1 1. An integrated circuit comprising: a gate array architecture;
- said gate array architecture including a semiconductor substrate having a plurality of N-type
- 3 diffusion regions and P-type diffusion regions; said diffusion regions having partially overlying
- 4 polysilicon landing sites to form N-type and P-type transistors;
- 5 wherein the regions are relatively-sized to form two distinct transistor sizes, smaller N- and
- 6 P-type transistors and larger N- and P-type transistors.
- 1 2. The integrated circuit of claim 1, wherein the ratio between the two distinct transistor sizes
- 2 is on the order of one-third.
- 1 3. The integrated circuit of claim 2, wherein the ratio between the capacitance of the larger and smaller relatively sized transistors is on the order of one-third.
  - 4. The integrated circuit of claim 1, wherein said partially overlying polysilicon landings for the smaller and larger transistors are not connected.
  - 5. The integrated circuit of claim 4, and further comprising an interconnect overlying said gate array architecture;

the interconnect being adapted to connect the transistors of the gate array architecture to form a flip-flop.

- 6. The integrated circuit of claim 5, wherein the interconnect is further adapted to connect the transistors of the gate array architecture so that the internal clock buffers of the flip-flop are formed from the smaller transistors.
- 7. The integrated circuit of claim 6, wherein said gate array architecture is repeated in said
- 2 integrated circuit.
- 1 8. The integrated circuit of claim 6, wherein said integrated circuit is incorporated in a
- 2 communications device.
- 1 9. The integrated circuit of claim 6, wherein said integrated circuit is attached to a
- 2 motherboard.
- 1 10. The integrated circuit of claim 9, wherein said integrated circuit is in incorporated in a
- 2 personal computer.
- 1 11. The integrated circuit of claim 10, wherein said personal computer comprises one of a
- 2 laptop and a desktop computer.
- 1 12. The integrated circuit of claim 1, wherein successive rows of small diffusion regions are
- 2 followed by successive rows of regular-sized diffusion regions;
- wherein immediately successive rows within similarly-sized diffusion regions have opposite
- 4 polarity.

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- 13. A method of fabricating an integrated circuit chip comprising:
- 2 processing a semiconductor substrate to form a gate array architecture of transistors in the
- 3 substrate, the gate array architecture comprising a plurality of N-type diffusion regions and P-type
- 4 diffusion regions; said diffusion regions having partially overlying polysilicon landing sites to form
- 5 N-type and P-type transistors;
- 6 wherein the regions are relatively-sized to form two distinct transistor sizes, smaller N- and
- 7 P-type transistors and larger N- and P-type transistors.
- 1 14. The method of claim 13, wherein said semiconductor substrate comprises a silicon
- 2 substrate.
  - 15. The method of claim 14, wherein processing said silicon substrate to form a gate array architecture comprises:

forming said partially overlying polysilicon landings so that said landings for the smaller and larger transistors are not connected.

- 16. The method of claim 15, wherein the ratio between the two distinct transistor sizes is on the order of one-third.
- 17. The method of claim 16, wherein the ratio between the capacitance of the larger and smaller relatively sized transistors is on the order of one-third.
- 18. The method of claim 15, and further comprising:
- forming a metallization interconnect overlying said gate array architecture.
- 19. The method of claim 18, wherein forming a metallization interconnect comprises forming a
- metallization interconnect that connects the transistors of the gate array architecture to form a
- 3 flip-flop.
- 1 20. The method of claim 19, wherein forming a metallization interconnect comprises forming
- 2 an interconnect that connects the transistors of the gate array architecture so that the internal
- 3 clock buffers of the flip-flop are formed from the smaller transistors.
- 1 21. An article comprising: a storage medium, said storage medium having instructions stored
- thereon, said instructions, when executed, resulting in the capability to design the layout of an
- 3 integrated circuit chip for fabrication, the integrated circuit chip including a gate array architecture,
- 4 the gate array architecture comprising a plurality of N-type diffusion regions and P-type diffusion
- 5 regions; said diffusion regions having partially overlying polysilicon landing sites to form N-type
- 6 and P-type transistors;
- 7 wherein the regions are relatively-sized to form two distinct transistor sizes, smaller N- and
- 8 P-type transistors and larger N- and P-type transistors.

- 1 22. The article of claim 21, wherein said instructions, when executed, result in the capability to
- 2 design the layout of the gate array architecture, wherein the ratio between the two distinct
- 3 transistor sizes is on the order of one-third.
- 1 23. The article of claim 22, wherein said instructions, when executed, result in the capability to
- 2 design the layout of the gate array architecture, wherein said partially overlying polysilicon
- 3 landings for the smaller and larger transistors are not connected.
- 1 24. The article of claim 23, wherein said instructions, when executed, result in the capability to
- 2 design the layout of a metallization interconnect overlying said gate array architecture.
- 1 25. The article of claim 24, wherein said instructions, when executed, result in the capability to
- 2 design the layout of a metallization interconnect overlying said gate array architecture, wherein
  - said metallization interconnect couples the transistors of the gate array architecture to form a flip-
  - flop.
  - 26. The article of claim 25, wherein said instructions, when executed, result in the capability to design the layout of a metallization interconnect overlying said gate array architecture that connects the transistors of the gate array architecture so that the internal clock buffers of the flip-flop are formed from the smaller transistors.